

INITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tatsuo ITO et al.

ATTN: Application Branch

Application No.: 10/502,389

Docket No.: 120503

Filed: July 26, 2004

For:

METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER, METHOD FOR RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER, AND SYSTEM FOR RECEIVING ORDER FOR MANUFACTURE OF

SEMICONDUCTOR WAFER

CORRECTED FILING RECEIPT STATUS REQUEST

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

A Request for Correction of PALM Records was filed on January 5, 2005. A copy of the postcard receipt is attached hereto. A copy of the Request for Correction of PALM Records is also attached.

The corrected Filing Receipt has not yet been received. It is respectfully requested that the corrected Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

lly submitted.

egistration No. 30,024

Philip A. Caramanica, Jr. Registration No. 51,528

WPB:PAC/cqc

Date: April 21, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

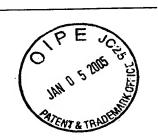


► Mail Room (Regular Delivery)

The following papers have been filed:

Request for Correction of PALM Records; Marked-up OFR							
Name of Applicant:	Tatsuo ITO et al.						
Serial No.:	10/502,389						
Atty. File No.:	120503						
Title (New Cases):							
Sender's Initials:	JAO/cqc	[81]	13				

PATENT OFFICE DATE STAMP



COPY TO BE STAMPED BY PATENT OFFICE
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PATENT APPLICATION

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SEMICONDUCTOR WAFER

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff Registration No. 27,075

Eric D. Morehouse Registration No. 38,565

JAO:EDM/cqc

Date: January 5, 2005

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1	APPL NO.	(c) DATE			420503	6	35	3	
•	10/502,389	07/26/2004	2812	1190	120503	•			

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CONFIRMATION NO. 3456 FILING RECEIPT

OC00000014830077

Date Mailed: 12/28/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Tatsuo Ito, Tokyo, JAPAN; Shigeyoshi Netsu, Fukushima, JAPAN; Masashi Ichikawa, Fukushima, JAPAN; Nobuhiro Ohara, Fukushima, JAPAN;

Power of Attorney:

Thomas Pardini-30411

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/00557 01/22/2003

Foreign Applications

JAPAN 200219334 01/29/2002

Projected Publication Date: 04/07/2005

Non-Publication Request: No

Early Publication Request: No

Title

Semiconductor wafer manufacturing retrod, semiconductor wafer mnaufacturing orderacceptance method, and semiconductor wafer manufacturing order acceptance system

Method for Manufacturing Semiconductor Water, Method Preliminary Class for Receiving Order for Manufacture of Semiconductor 438 Water and System for Receiving Order for Manufacture

Title 35, Code of Federal Regulations, 5.11 & 5.15

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